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Attention: Mail Stop AF
Response Under 37 C.F.R. § 1.116
Expedited Procedure Requested
Examining Group 2823

PATENT
Customer No. 22,852
Attorney Docket No. 04329.2622

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:

Gaku MINAMIHABA, et al.

Serial No.: 09/932,943

Filed: August 21, 2001

For: SLURRY FOR CHEMICAL
MECHANICAL POLISHING AND
METHOD OF MANUFACTURING
SEMICONDUCTOR DEVICE

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

SUPPLEMENTAL AMENDMENT AFTER FINAL

Supplemental to the Amendment After Final filed on July 24, 2003, Applicants propose further amending the application as follows.

Amendments to the Claims are reflected in the listing of claims which begins on page 2 of this paper.

Remarks/Arguments begin on page 10 of this paper.

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THE FEDERAL CIRCUIT

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